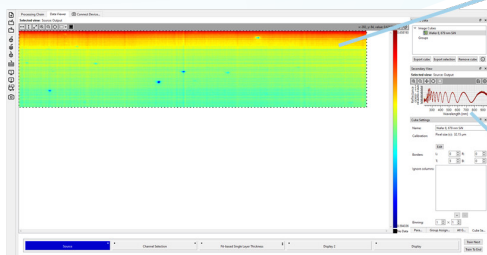


## PoliSpectra<sup>®</sup> UV-VIS-NIR Hyperspectral System for INSPECTION (Materials/Wafers/Food...)

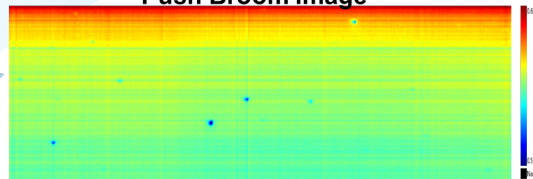
- H116 IMAGING SPECTROMETER
- 200-800 or 400-800 nm
- UV Grade or VIS Objective options
- 1.2 nm spectral resolution
- **Push-broom hyperspectral configuration**
- **Multilayer Wafer thickness analysis**
- **Imaging software – Builds your hyperspectral cube**
- XENON Flash Lamps
- Uniform Illuminator
- Märzhäuser XY stage w/wafer holder
- Wafers size of up to 250 x 250 mm

### SiN 664 nm coated Si Wafer

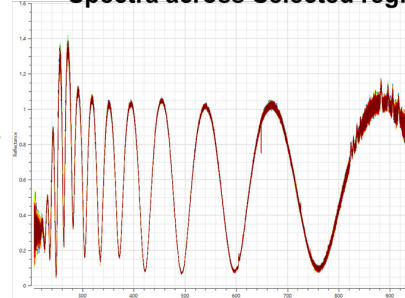
#### Initial Cube data



#### Push Broom Image



#### Spectra across Selected region



For OEM Industrial Applications

**SPECTROSCOPY & IMAGING**

Design & Manufacturing in the USA

